504338075 04/26/2017

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT4384763

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
STEFAN SCHUBERT	09/13/2016
THOMAS KEMEN	07/20/2016
RAINER KNIPPELMEYER	07/15/2016

RECEIVING PARTY DATA

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City:	REHOVOT	
State/Country:	ISRAEL	
Postal Code:	76705	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	15026189

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER: 030290-002310US

NAME OF SUBMITTER: AMELIA KHALAF

PATENT 504338075 REEL: 042144 FRAME: 0558

SIGNATURE:	/Amelia Khalaf/	
DATE SIGNED:	04/26/2017	
Total Attachments: 2		
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PATENT REEL: 042144 FRAME: 0559

Docket No.: 030290-002310US

ASSIGNMENT OF PATENT APPLICATION

WHEREAS, each of the following:

Stefan SCHUBERT, a resident of Oberkochen, DE; Thomas KEMEN, a resident of Meppen, DE; and Rainer KNIPPELMEYER, a resident of Herrsching am Ammersee, DE;

hereinafter referred to as "Assignor," is an inventor of the invention described and set forth in the below-identified application for United States Letters Patent:

Title of Invention: CHARGED PARTICLE BEAM SYSTEM AND

METHOD OF OPERATING THE SAME

Filing Date: March 30, 2016

Application No.: 15/026,189; and

WHEREAS, Carl Zeiss Microscopy GmbH, a corporation located at Carl-Zeiss-Promenade 10, 07745, Jena, 07745, DE, and Applied Materials Israel, Ltd., a corporation located at 9 Oppenheimer Street, Rehovot, 76705, IL, jointly referred to hereinafter referred to as "Assignees," is desirous of acquiring an interest in the invention and application and in any U.S. Letters Patent and Registrations which may be granted on the same;

For good and valuable consideration, receipt of which is hereby acknowledged by each Assignor, each Assignor has assigned, and by these presents does assign to Assignee all right, title and interest in and to the invention and application and to all foreign counterparts (including patent, utility model and industrial designs), and in and to any Letters Patent and Registrations which may hereafter be granted on the same in the United States and all countries throughout the world, including any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof, and to claim the priority from the application as provided by the Paris Convention. The right, title and interest is to be held and enjoyed by Assignee and Assignee's successors and assigns as fully and exclusively as it would have been held and enjoyed by each and all Assignors had this Assignment not been made, for the full term of any Letters Patent and Registrations which may be granted thereon, or of any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof.

Each Assignor further agrees that he/she will, without charge to each Assignor, and at Assignee's expense, (a) cooperate with Assignee in the prosecution of U.S. Patent applications and foreign counterparts on the invention and any improvements, (b) execute, verify, acknowledge and deliver all such further papers, including patent applications and instruments of transfer, and (c) perform such other acts as Assignee lawfully may request to obtain or maintain Letters Patent and Registrations for the invention and improvements in any and all countries, and to vest title thereto in Assignee, or Assignee's successors and assigns.

Each Assignor hereby authorizes and requests Morris & Kamlay LLP, 1150 18th St NW, Suite 575, Washington, DC 20036, to insert herein above the application number and filing date of said application when known.

IN TESTIMONY WHEREOF, Each Assignor has signed on the date indicated.

Dated: 546, 19, 2016	G. Gellenk
Dated: Jul. 20, 2016	Stefan SCHUBERT Thomas hene
Dated:	Thomas KEMEN
	NO. 3 K. S.

Rainer KNIPPELMEYER

Docket No.: 030290-002310US

ASSIGNMENT OF PATENT APPLICATION

WHEREAS, each of the following:

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For good and valuable consideration, receipt of which is hereby acknowledged by each Assignor, each Assignor has assigned, and by these presents does assign to Assignee all right, title and interest in and to the invention and application and to all foreign counterparts (including patent, utility model and industrial designs), and in and to any Letters Patent and Registrations which may hereafter be granted on the same in the United States and all countries throughout the world, including any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof, and to claim the priority from the application as provided by the Paris Convention. The right, title and interest is to be held and enjoyed by Assignee and Assignee's successors and assigns as fully and exclusively as it would have been held and enjoyed by each and all Assignors had this Assignment not been made, for the full term of any Letters Patent and Registrations which may be granted thereon, or of any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof.

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IN TESTIMONY WHEREOF, Each Assignor has signed on the date indicated.

Dated:	
	Stefan SCHUBERT
Dated:	
Dated: 07/15/7016	Thomas KEMEN
Dates: O 111 V La 14	Raiger KNIPPELMEVER

PATENT

REEL: 042144 FRAME: 0561

RECORDED: 04/26/2017